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SERIAL NUMBER 10/694,826	FILING DATE 10/29/2003 RULE	CLASS 257	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. 032060	
APPLICANTS Tamotsu Owada, Kawasaki, JAPAN; Shun-ichi Fukuyama, Kawasaki, JAPAN; Hirofumi Watatani, Kawasaki, JAPAN; Kengo Inoue, Kawasaki, JAPAN; Atsuo Shimizu, Kawasaki, JAPAN; ** CONTINUING DATA ** ** FOREIGN APPLICATIONS ** JAPAN 2002-315900 10/30/2002 JAPAN 2003-360192 10/21/2003 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/30/2004					
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: <i>N. Daniel</i> Initials: <i>MD</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 30	INDEPENDENT CLAIMS 8
ADDRESS 38834 WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP 1250 CONNECTICUT AVENUE, NW SUITE 700 WASHINGTON, DC 20036					
TITLE Silicon oxycarbide, growth method of silicon oxycarbide layer, semiconductor device and manufacture method for semiconductor device					
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